



# RADICAL PLASMA SOURCE (REMOTE PLASMA SOURCE) - MA2000C-713BB

**Category:** Plasma components

## ADDITIONAL INFORMATION

|                                  |                                              |
|----------------------------------|----------------------------------------------|
| <b>Typ</b>                       | Radical plasma source (Remote Plasma Source) |
| <b>Process</b>                   | Etching & Deposition                         |
| <b>Output Connection Type</b>    |                                              |
| <b>Dielectric material</b>       | Ceramics                                     |
| <b>Mains voltage nominal [V]</b> | 230 / 208                                    |
| <b>Output Power CW [W]</b>       | 2000                                         |
| <b>Frequency [MHz]</b>           | 2450                                         |